

INFORMATION DISCLOSURE CITATION

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Applicant	Masahiko HASUNUMA et al.		
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U.S. PATENT DOCUMENTS							
Examiner Initial*		Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
DHL		6,037,668	03/14/2000	Cave et al.			

FOREIGN PATENT DOCUMENTS							
		Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
DHL		11-176835	07/02/1999	Japan			No
		11-307633	11/05/1999	Japan			No
		2001-267323	09/28/2001	Japan			No
		2001-196372	07/19/2001	Japan			No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
DHL	Kurashima et al; "SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD"; U.S. Patent Application No. 10/640,004, filed August 14, 2003

Examiner	Kang, Donghee	Date Considered	11-27-04
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